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THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Stephen L. Buchwalter, et al.

Docket: 14029

Patent No.: 6.924.171 B 2_

Dated: August 16, 2005

Issued: August 02, 2005

For: BILAYER WAFER-LEVEL UNDERFILL

Certificate

AUG 2 4 2005

of Correction

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

REQUEST FOR CERTIFICATE OF CORRECTION

Sir:

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It appears that errors have been introduced in the course of printing the Patent issued in the above application, and it is respectfully requested that the

Commissioner issue a Certificate of Correction in the following respects:

Column 3, Line 42:

"and all other II/V" should read -- and all other III/V --

Column 7, Line 4, Claim 2:

"vapor deposition (CYD)" should read -- vapor deposition (CVD) --

Respectfully submitted

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UNITED STATES PATENT AND TRADEMARK OFFICE **CERTIFICATE OF CORRECTION**

PATENT NO

: 6,924,171 B2

APPLICATION NO: 09/782,494

ISSUE DATE

: August 02, 2005

INVENTOR(S)

: Stephen L. Buchwalter, et al.

It is certified that an error appears or errors appear in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Column 3, Line 42:

"and all other II/V" should read -- and all other III/V --

Column 7, Line 4, Claim 2:

"vapor deposition (CYD)" should read -- vapor deposition (CVD) --

MAILING ADDRESS OF SENDER:

PATENT NO. 6,924,171

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